



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akira SATO

Group Art Unit: 2825

Application No.: 09/424,500

Examiner: G. Lee, Jr.

Filed: February 22, 2000

Docket No.: 104788

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING
DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE

REQUEST FOR APPROVAL OF DRAWING CORRECTIONS

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

The Examiner is requested to review and approve the proposed corrections to Figure
2, marked in red on the attached copy of such drawing figure.

Upon approval by the Examiner, and upon allowance of this application, the formal
drawings will be corrected.

Respectfully submitted,

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JUL 13 2002
TECHNOLOGY CENTER 2800
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